



*Image*  
*AT 2851/\$*

PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.2348

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
)  
Iwao HIGASHIKAWA )  
)  
Application No.: 09/615,605 ) Group Art Unit: 2851  
)  
Filed: July 13, 2000 ) Examiner: Cruz, Magda  
)  
For: PATTERN FORMING METHOD AND )  
LIGHT EXPOSURE APPARATUS )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TIME**

Applicant hereby petitions for a two-month extension of time to reply to the Office Action of September 16, 2003. Since February 16, 2004 was a Federal holiday, the time for reply extends through February 17, 2004. A fee of \$410.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: February 17, 2004

By: *Richard V. Burgujian*  
*for* Richard V. Burgujian  
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